Atty. Dkt. No. 040256-0135 DT01 Rec'd PCT/PTC 2 0 OCT 2004

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Shuji HAHAKURA, et al.

Title:

METHOD OF PRODUCING OXIDE SUPERCONDUCTING FILM

Appl. No.:

Unassigned

Filing Date: October 20, 2004

Examiner:

Unassigned

Art Unit:

Unassigned

## PRELIMINARY AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Application, Applicant respectfully requests that the application be amended as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: